

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Eun-Taek YIM, et al.

Serial No.: 10/734,479 Examiner: Chaudhry, Saeed T.

Filed: December 12, 2003 Art Unit: 1746

Confirmation No.: 9601

For: METHOD FOR CLEANING A DEPOSITION CHAMBER AND
DEPOSITION APPARATUS FOR PERFORMING IN SITU
CLEANING

Mail Stop Issue Fee
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

**APPLICANT'S COMMENTS ON EXAMINER'S STATEMENT OF REASONS FOR
ALLOWANCE**

In the Examiner's Statement of Reasons for Allowance, the Examiner recited portions of the allowed independent claims and stated that none of the prior art discloses or suggests the recited portions. The applications note that it is a well-known tenet of patent law that each allowed patent claim stands alone. Further, although the Examiner has indicated at least one reason for allowance, there are other reasons that claims are allowable. In other words, the Examiner has not recited all of the reasons for allowance, and there are reasons for allowability in addition to those given by the Examiner.

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Respectfully submitted,
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